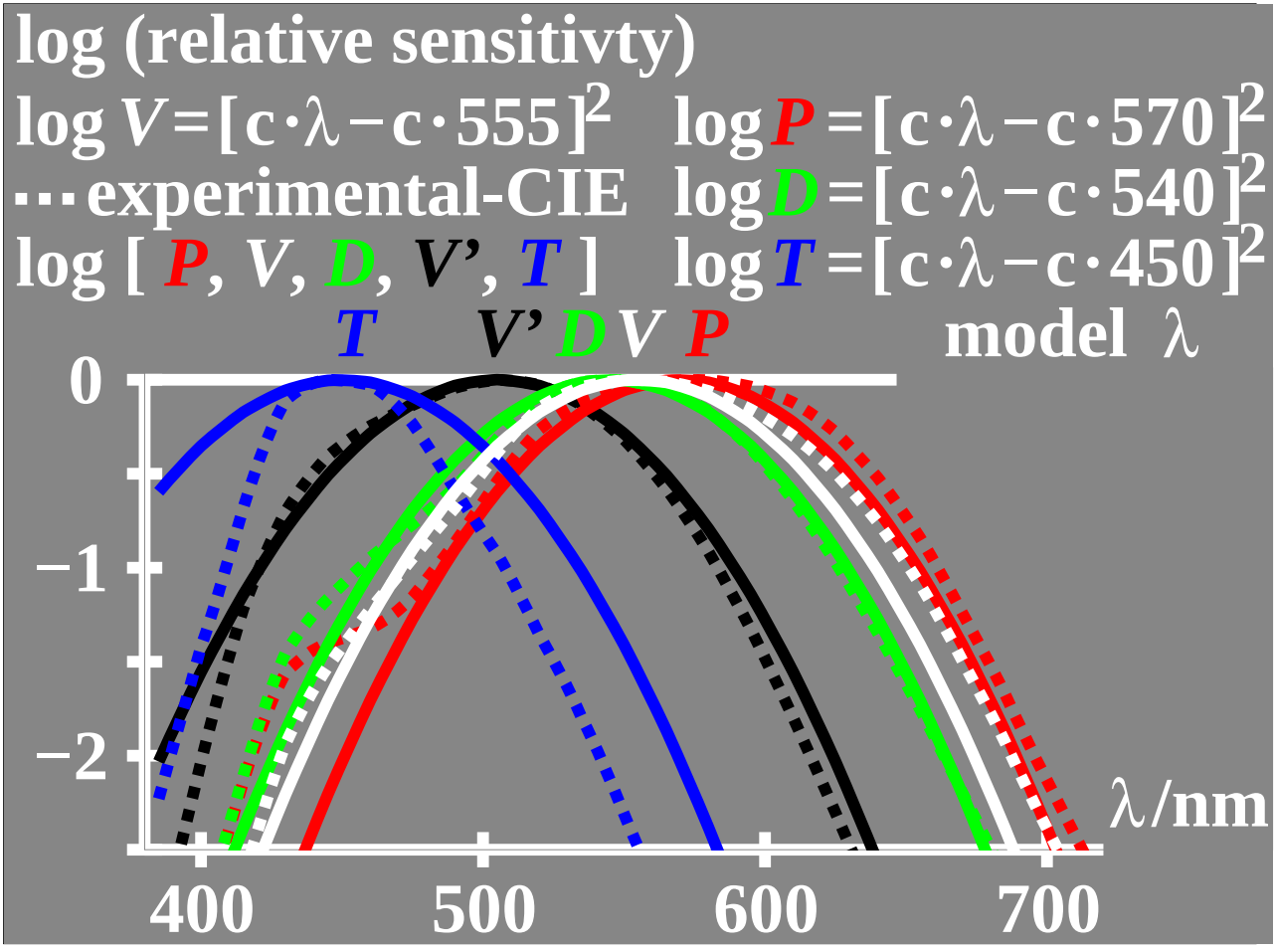
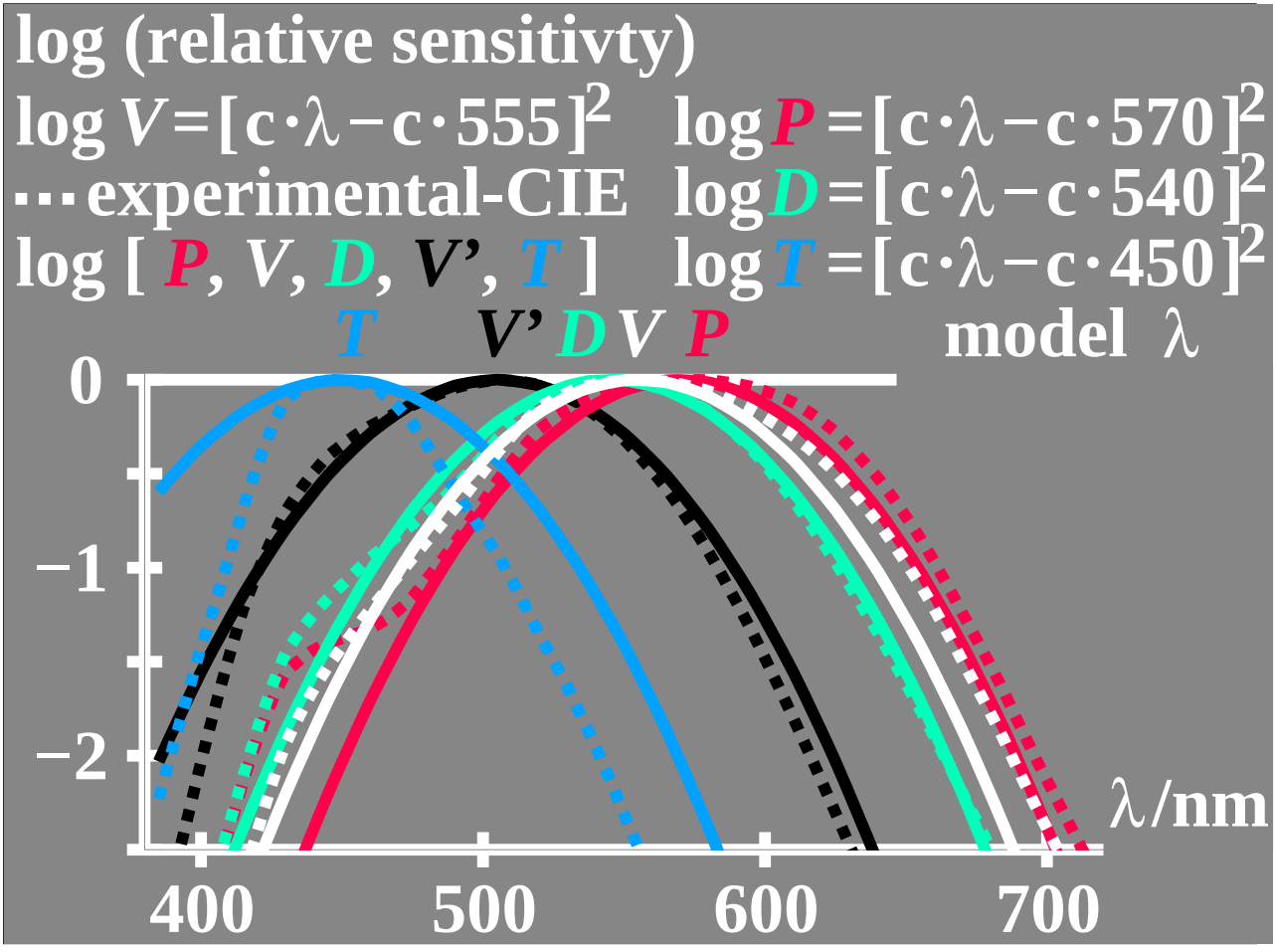
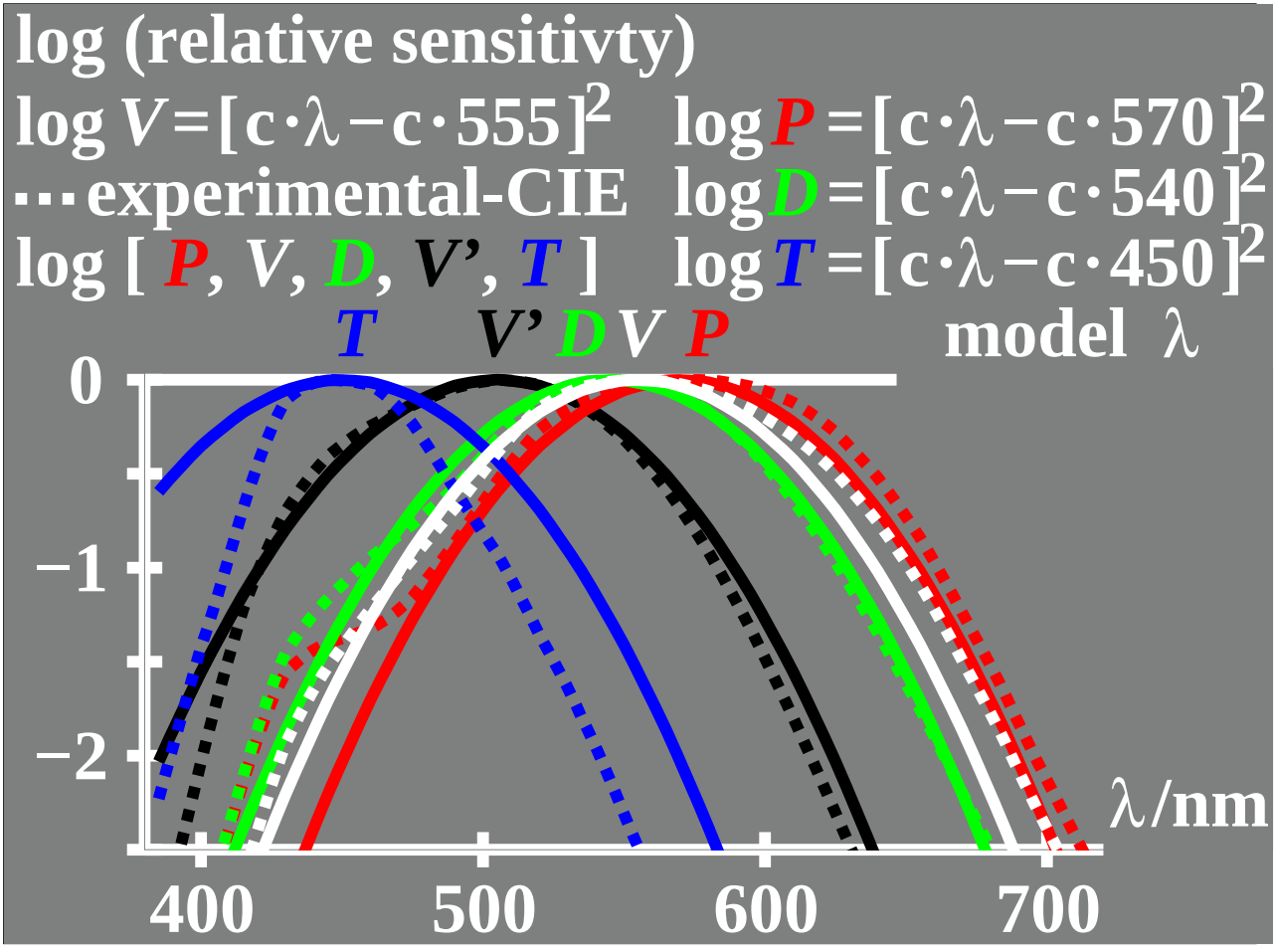
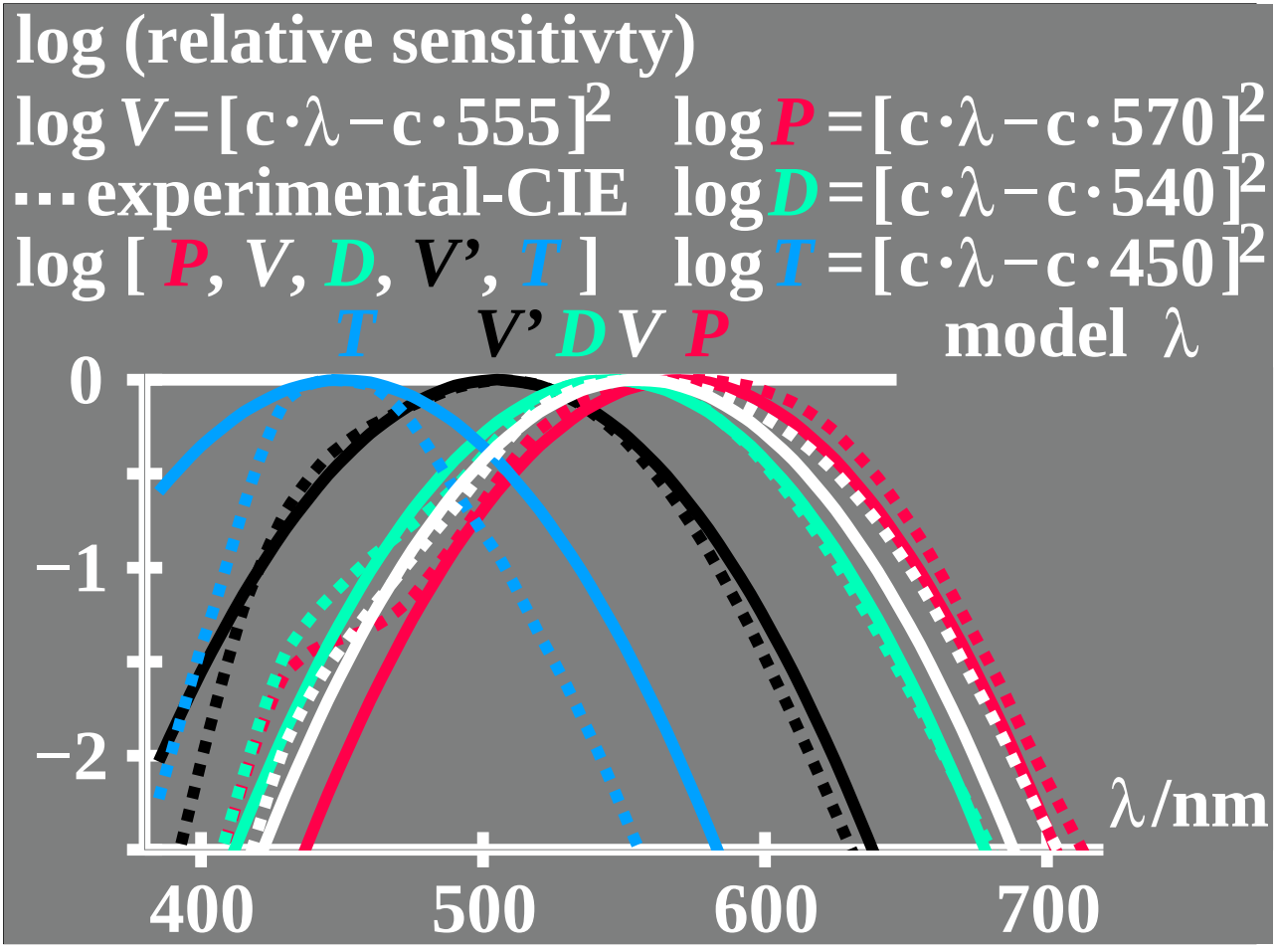

log (relative sensitivty)
log V=[c·λ−c·555]2
log P=[c·λ−c·570]2
…experimental-CIE
log D=[c·λ−c·540]2
log [P, V, D, V', T]
log T=[c·λ−c·450]2
T V' D V P
model λ
0
−1
−2
λ/nm
400
500
600
700



1−013130−L0 1−013130−F0 ME100−64/ME490−61



1−103130−L0 1−103130−F0 ME100−64/ME490−62



1−113130−L0 1−113130−F0 ME100−64/ME490−63